

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE <div style="border: 1px solid black; border-radius: 50%; padding: 5px; display: inline-block; text-align: center;">           MAY 03 2004            PATENT &amp; TRADEMARK OFFICE         </div>		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin Li, et al.		FILING DATE September 1, 1999	
GROUP 2813							

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ER	AA	6,503,818 B1	01/2003	Jang			
	AB	6,486,061 B1	11/2002	Xia et al.			
	AC	6,486,057 B1	11/2002	Yeh et al.			
	AD	6,465,372 B1	10/2002	Xia et al.			
	AE	6,444,593 B1	09/2002	Ngo et al.			
	AF	6,436,808 B1	08/2002	Ngo et al.			
	AG	6,435,943 B1	08/2002	Chang et al.			
	AH	6,429,115 B1	08/2002	Tsai et al.			
	AJ	6,284,677 B1	09/2001	Hsiao et al.			
	AJ	6,030,901	02/2000	Hopper et al.			
	AK	6,133,618	10/2000	Steiner			
	AL	5,994,217	11/1999	Ng			

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
		AM 8046186	02/1996	Japan				
ER	AN	8046186	2/1996	Japan			X	
	AO	7201716	08/1995	Japan				
ER	AP	7201716	08/1995	Japan			X	
ER	AQ	8046188	02/1996	Japan				

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
ER	AR		Wolf, S., Silicon Process., V.1 407-413.
Ch	AS		Wolf, S., Silicon Process., Vol 2 48-49 and 435.
ER	AT		Wolf, S., Silicon Processing for the VLSI Era, Vol. 3, page 635.

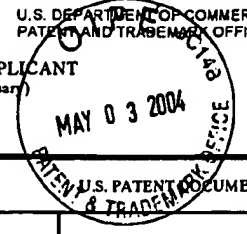
  

EXAMINER <span style="font-family: cursive;">E-K</span>	DATE CONSIDERED 6/8/2004
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
EK	AA	3,985,519	11/1999	Kakamu et al.		
	AB	5,747,388	05/1998	Kusters et al		
	AC	5,639,687	06/1997	Roman et al		
	AD	5,498,555	03/1996	Lin		
	AE	6,153,504	11/2000	Shields et al		
	AF	4,971,655	11/1990	Stefano et al		
	AG	6,498,084	12/2002	Bergemont		
	AH	5,036,383	07/1991	Mori		
	AI					
	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
EK	AM	6232113	08/1994	Japan				
	AN	8051058	02/1996	Japan				
	AO	63316476	12/1988	Japan				
	AP	8078322	03/1996	Japan				
	AQ	10-163083	06/1998	Japan				
	AR	08-045926A	02/1996	Japan				

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AS			
AT			

EXAMINER EK	DATE CONSIDERED 6/8/2004
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